

U.S. PATENT & TRADEMARK OFFICE
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**Associate Power Of Attorney Or Agent (37 CFR 1.34)
(For Representation Related To A Patent Application)**

Docket No.
BU9-99-197

In Re: Application Of:
Furukawa, et al.

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Examiner
Maldonado, Julio J.

Group Art Unit
2825

Invention: **METHOD FOR ETCHING A SEMICONDUCTOR SUBSTRATE USING GERMANIUM HARD MASK**

TO THE ASSISTANT COMMISSIONER FOR PATENTS:

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Dated: **June 11, 2002**

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